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Debra M. Szumowski

Name

Signature

DOCKET: CU-3305

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICANT: Joon Hyeon Lee )  
SERIAL NO: 10/622,351 ) Group Art Unit: 2812  
FILING DATE: July 18, 2003 ) Examiner:  
TITLE: METHOD FOR FORMING ISOLATION )  
FILM FOR SEMICONDUCTOR DEVICES )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Dear Sir:

The official filing receipt has been received from the Patent Office in the above application.

There is an error in that the filing date of the Korean priority application is incorrect as marked on the attached copy of the filing receipt. Reference is made to page 3 of the Combined Declaration & Power of Attorney initially filed in this application.

It is believed that no fee is due since the correction is not due to any error by the applicant and issuance of a corrected filing receipt is respectfully requested.

Respectfully submitted,

November 6, 2003

Date

/10

Attorney for Applicant

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 CHICAGO  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/622,351	07/18/2003	2812	750	CU-3305 RJS	6	17	1

CONFIRMATION NO. 4792

 26530  
 LADAS & PARRY  
 224 SOUTH MICHIGAN AVENUE, SUITE 1200  
 CHICAGO, IL 60604

## FILING RECEIPT



\*0000000011070762\*

Date Mailed: 10/21/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Joon Hyeon Lee, Chungcheongbuk-do, KOREA, REPUBLIC OF;

## Domestic Priority data as claimed by applicant

## Foreign Applications

10-9-2002

REPUBLIC OF KOREA 2002-77969 ~~0042/2002~~

If Required, Foreign Filing License Granted: 10/20/2003

Projected Publication Date: 03/18/2004

Non-Publication Request: No

Early Publication Request: No

## Title

Method for forming isolation film for semiconductor devices

## Preliminary Class

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